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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1725
PATENT APPLICATION

\$AP/1725
16th
JAA
7/24/03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

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PE

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Advisory Action dated June 24, 2003 and the Final Office Action dated February 13, 2003, along with a Petition for Extension of Time and appropriate fee, please amend the above-identified application as follows on the accompanying pages and as allowed by the new format specified in the Pre-OG Notice of January 31, 2003, entitled, *Amendments in a Revised Format Now Permitted*, wherein the requirements of 37 C.F.R. § 1.121 (a - d) have been waived.